



AF
IFW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Huotari
Appl. No. : 10/601,037
Filed : June 19, 2003
For : METHOD TO FABRICATE
DUAL METAL CMOS DEVICES
Examiner : Christy L. Novacek
Group Art Unit : 2822

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

June 2, 2005

(Date)

Adeel S. Akhtar
Adeel S. Akhtar, Reg. No. 41,394

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Final Office Action mailed on March 2, 2005. As they are believed to place the application in condition for allowance and do not require extensive consideration by the Examiner or additional searching, Applicants respectfully request entry of the following amendments and consideration of the subsequent remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

AmB
Inter
PCES-05
7-5-05
Shank
7/12/05